

F m PTO-1449 U.S.Department of Commerce (Rev. 8-83) Patent and Trademark Office

Atty Docket 0756-2394

Serial No. Unassigned

INFORMATION DISCLOSURE STATEMENT

Applicants: Hongyong ZHANG et al.

Filing Date: Group Art Unit: Unassigned

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kaminer itial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate
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BX	5,064,775	11/12/1991	Chang		-/\	ļ —
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5,580,792 5,585,291 5,589,694 5,595,923 5,595,944 5,604,360 5,605,846 5,606,179 5,608,232 5,612,250	12/03/1996 12/17/1996 12/31/1996 01/21/1997 01/21/1997 02/18/1997 02/25/1997 03/04/1997 03/18/1997	Zhang et al. Ohtani et al. Takayama et al. Zhang et al. Zhang et al. Zhang et al. Ohtani et al. Yamazaki et al. Ohtani et al. Ohtani et al.			
5,585,291 5,589,694 5,595,923 5,595,944 5,604,360 5,605,846 5,606,179 5,608,232 5,612,250	12/17/1996 12/31/1996 01/21/1997 01/21/1997 02/18/1997 02/25/1997 02/25/1997 03/04/1997	Ohtani et al. Takayama et al. Zhang et al. Zhang et al. Zhang et al. Zhang et al. Ohtani et al. Yamazaki et al. Ohtani et al.			
5,589,694 5,595,923 5,595,944 5,604,360 5,605,846 5,606,179 5,608,232 5,612,250	12/31/1996 01/21/1997 01/21/1997 02/18/1997 02/25/1997 02/25/1997 03/04/1997	Takayama et al. Zhang et al. Zhang et al. Zhang et al. Zhang et al. Ohtani et al. Yamazaki et al. Ohtani et al.			
5,595,923 5,595,944 5,604,360 5,605,846 5,606,179 5,608,232 5,612,250	01/21/1997 01/21/1997 02/18/1997 02/25/1997 02/25/1997 03/04/1997 03/18/1997	Zhang et al. Zhang et al. Zhang et al. Zhang et al. Ohtani et al. Yamazaki et al. Ohtani et al. Ohtani et al.			
5,595,944 5,604,360 5,605,846 5,606,179 5,608,232 5,612,250	01/21/1997 02/18/1997 02/25/1997 02/25/1997 03/04/1997 03/18/1997	Zhang et al. Zhang et al. Ohtani et al. Yamazaki et al. Yamazaki et al. Ohtani et al.			
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5,605,846 5,606,179 5,608,232 5,612,250	02/25/1997 02/25/1997 03/04/1997 03/18/1997	Ohtani et al. Yamazaki et al. Yamazaki et al. Ohtani et al.			
5,606,179 5,608,232 5,612,250	02/25/1997 03/04/1997 03/18/1997	Yamazaki et al. Yamazaki et al. Ohtani et al.			
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Form PTO-1449 (Rev. 8-83) U.S.Department of Commerce Patent and Trademark Office

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Examiner Brook Kehedl Date Considered July 2, 2003

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					•	Sheet 6
orm PTO- (Rev. 8-83)		U.S.Department		Atty Docket 0756-	2394	Serial No. Unassigned
		DISCLOSURE STATEM		Applicants: Hong	yong ZHANG et	al.
	VI ORMATION I	AGGEOGRAZ STATEME		Filing Date:		Group Art Unit:
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IN	FORMATION DISCLOSURE ST.	ATEMENT	Applicants: Hongyong	ZHANG et al		
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F m PTO-1449 U.S.D partment of Comme Atty Docket 0756-2394 Serial No. 09/993,492 Patent and Trademark Office (Rev. 8-83) Applicants: Hongyong ZHANG et al. TION DISCLOSURE STATEMENT Filing Date: November 27, 2001 Group Art Unit: 2823 FOREIGN PATENT DOCUMENTS Date Document Number Country Subclass Translation Yes No Full Eng 01/30/1990 02-027320 JP 02-228043 09/11/1990 JP Eng Abst Bal 03/11/1988 Eng Abst 63-056912 JP

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